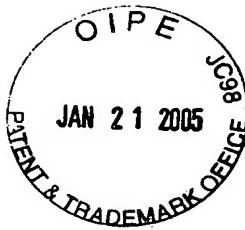


Attorney Docket: 081468-0307255
Client Reference: P-1514.010-US



IFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of:
LEON MARTIN LEVASIER ET AL.
Application No.: 10/736,230

Confirmation Number: 3133
Group Art Unit: 2851
Examiner: Hung Nguyen

Filed: December 16, 2003

Title: LITHOGRAPHIC APPARATUS WITH ALIGNMENT SUBSYSTEM, DEVICE MANUFACTURING METHOD, AND DEVICE MANUFACTURED THEREBY

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated December 22, 2004, Applicants hereby elect the invention of Group I, which includes claims 1-48, for examination. This election is made without traverse. Unelected claims 49-56 are withdrawn from further consideration in this application.

Prompt and favorable examination on the merits is respectfully requested.

Respectfully submitted,

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